WEST

Generate Collection

Print

Search Results - Record(s) 1 through 1 of 1 returned.

1. Document ID: JP 52111891 A

L3: Entry 1 of 1

File: DWPI

Sep 19, 1977

DERWENT-ACC-NO: 1977-78360Y

DERWENT-WEEK: 197744

COPYRIGHT 2002 DERWENT INFORMATION LTD

TITLE: Metal surface treatment to increase hardness - comprises hardening base metal and depositing e.g. molybdenum film

PATENT-ASSIGNEE:

ASSIGNEE

CODE

HONDA MOTOR IND CO LTD

HOND

PRIORITY-DATA: 1976JP-0028633 (March 18, 1976)

PATENT-FAMILY:

PUB-NO

PUB-DATE

LANGUAGE

PAGES

MAIN-IPC

JP 52111891 A

September 19, 1977

000

INT-CL (IPC): C23C 11/00; C23C 13/00; C23C 15/00

ABSTRACTED-PUB-NO: JP 52111891A

BASIC-ABSTRACT:

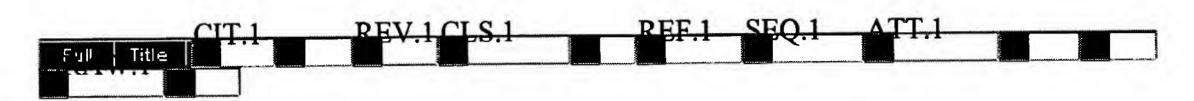
Metal film is formed on the hardened surface of a base metal. Method comprises subjecting a base metal to hardening treatment and then subjecting the hardened surface of the base metal to gas phase surface treatment such as ion-plating, spattering, or TiC deposition to form a hard metal film having high m. pt. such as, Mo, W, Cr, Ni, TiC or TiN.

The hardening treatment is, for example, ion-nitriding or carbonising-nitriding. The hardness of the metal surface can be increased in a simple process.

TITLE-TERMS: METAL SURFACE TREAT INCREASE HARD COMPRISE HARDEN BASE METAL DEPOSIT MOLYBDENUM FILM

DERWENT-CLASS: M13

CPI-CODES: M13-D; M13-F; M13-G; M13-H04;



Generate Collection

Print

Terms	Documents
jp-52111891-\$.did.	

Display Format: FULL

Change Format

Previous Page

Next Page

DERWENT-ACC-

1977-78360Y

NO:

DERWENT-

197744

WEEK:

COPYRIGHT 1999 DERWENT INFORMATION LTD

TITLE:

Metal surface treatment to increase hardness - comprises hardening base metal and

depositing e.g. molybdenum film

PATENT-ASSIGNEE: HONDA MOTOR IND CO LTD[HOND]

PRIORITY-DATA: 1976JP-0028633 (March 18, 1976)

PATENT-FAMILY:

PUB-NO

PUB-DATE

LANGUAGE PAGES MAIN-IPC

JP 52111891 A September 19, 1977 N/A

000

N/A

INT-CL (IPC): C23C011/00, C23C013/00, C23C015/00

ABSTRACTED-PUB-NO: JP 52111891A

BASIC-ABSTRACT:

Metal film is formed on the hardened surface of a base metal. Method comprises subjecting a base metal to hardening treatment and then subjecting the hardened surface of the base metal to gas phase surface treatment such as ion-plating, spattering, or <u>TiC</u> deposition to form a hard metal <u>film</u> having high m. <u>pt</u>. such as, Mo, W, Cr, Ni, TiC or TiN.

The hardening treatment is, for example, ion-nitriding or carbonising-nitriding. The hardness of the metal surface can be increased in a simple process.

TITLE-

METAL SURFACE TREAT INCREASE HARD COMPRISE HARDEN BASE

TERMS:

METAL DEPOSIT MOLYBDENUM FILM

DERWENT-CLASS: M13

CPI-CODES: M13-D; M13-F; M13-G; M13-H04;

19日本国特許庁

公開特許公報

①特許出願公開

昭52—111891

 ①Int. Cl². C 23 C 13/00 C 23 C 11/00 C 23 C 15/00 	識別記号	⑤日本分類 13(7) D 6 12 A 25 12 A 26 12 A 27 12 A 3	庁内整理番号 7128—42 7128—42 7128—42 7128—42 7619—42	43公開 昭和52年(1972年)発明の数 1審査請求 未請求	77)9月19日 (全 5 頁)
	12 A 3 20(3) E 0	7619—42 6816—41	•	(E O R)	

匈金属の表面処理方法

②特 願 昭51-28633

②出 願 昭51(1976)3月18日

⑩発 明 者 畠山重躬

東京都練馬区小竹町 2 -55

70発 明 者 瀬谷茂久

狭山市富士見 1 -15-9

切出 願 人 本田技研工業株式会社

東京都渋谷区神宮前6丁目27番

8号

個代 理 人 弁理士 下田容一郎 外1名

PTO 2003-1244 S.T.I.C. Translations Branch

明 細 幫

1. 発明の名称

金属の表面処理方法

2. 特許請求の範囲

表面硬化処理可能な金属材料からなる基材表面で、次に、次に、企業を施して使化を形成し、次のでイオンプレーティング法・スペッタリング法・TiC被優法等の気相表面処理法に、といる。W、Cr.Ni、TiC、TiN等の高融を形成するようにしたことを特徴とする金属の表面処理方法。

3. 発明の詳細な説明

ング法、TiC被殺法等の気相表面処理を施こし、 高便度で耐摩耗性を向上させた金属製品を得ること ができるようにした表面処理方法に関する。

機械の高速摺動部、例えばパルプロッカーアーム、デフピニオンシャフト等は、助げ、捻りに強いこと等の条件を要求される他、耐熱性、耐学社性等の苛酷な条件に適合するものであることが要求される。

従つて前記した機械部品等を前記条件に適合させるため、従来では次の如き表面処理法を採用している。

即ち、基材表面にMo,W等の高融点金属をブラズマ溶射等で溶射する方法。電気メッキ法で癌材表面に硬質クロムメッキ被覆を行う方法、或は茶材に浸炭窒化法やガス軟窒化。塩浴窒化。イオン 窒化等の窒化硬化法で表面硬化処理を施したものが用いられている。

このような従来手段において、前記した溶射法では後加工が頗る面倒且つ困難で、工具寿命その他でも問題を生じること、又剝離発生の可能性が

あり、別離強度の点でも問題がある。又前配メンキ層の境界部に別離が生しる。 中心理法では基材とメンキ層の境界部に別離が生 しめば、且では、日の処理を必要としる。 というのでは、の間ののののでは、 のののでは、 のののでは、 のののでは、 のののでは、 のののでは、 のののでは、 のののでは、 ののでは、 ののでは

本発明者等は前記の如く機械的強度,耐熱性,耐燃耗性等の苛酷な条件を要求される機械部品等の表面処理方法における前記した如き現状,問題点に鑑み、曲げ,総り等の機械的強度に優れ、自動性,耐摩耗性に優れた金属製品を得るべく鋭意研究し、本発明を成したものである。

本発明者等は、イオンプレーテイング法・スパッタリング法・TiC法等の気相表面処理法に着目し、これによつて表面処理を行うべく諸種研究はため、低級材の表面に直接 Cr,Mo 等の高融点を属をコーティング膜を厚くしなければヘルッ応力

- 3 -

得られ、以上を経済的且つ董産可能に得ることが できる表面処理方法を提供することを目的とする。 以下に本発明の一実施例を忝付図面に従つて詳 述する。

本発明にかかる表面処理方法には表面硬化処理可能な金属材料が用いられる。この材料的の安全の一般を受けるので、従って比較的の安全の一般を表している。この材料が出る。この材料が出る。この材料が出る。との表面ではできない。との表面ではできない。といるではできない。といるでは、塩浴室化法・ガスを登化法等で行い、ため、塩浴のの硬度を向上させて基材を強化さる。

次いで表面硬化処理を施した基材に Mo,W,Cr,Ni,TiC,TiN 等の高融点硬質金属類をイオンプレーティング法、スペッタリング法、或は TiC 被 複法等の気相表面処理を施し、硬化層 b の表面に 耐摩耗性の金属被 移層 c を形成し、 最終的に耐熱性,耐摩耗性等の前記した苛酷な条件に耐える金属材を得る。

従つて本発明の目的とする処は、機械指動部の 如く苛酷な条件を要求される機械部品等の表面処理方法として、曲げ、捻り等の機械的強度に優れ、 目の耐熱性、耐摩性に優れ、前記染件を充分に満足する金属製品を得ることができる 表面処理方法を提供する。

又本発明は、基材として装面硬化処理可能な業材であれば良く、例えば SCM22. S45C 等の安価な低級材を用いることができ、従つて安価な業材で前記した如き条件を充分に満足する金属製品が

- 4 -

た得る金属材が得られた。又これ等一連の処理等のとれては、下地金属の便便が高いいたが高い地域である。又が高い地域である。以前では、大きののでは、大きのでは、大きのでは、大きのでは、大きのでは、大きのでは、大きのでは、大きのでは、大きのでは、大きのでである。

以上を第2図のグラフで説明する。グラフはたまストピースをデフピニオンシャフトとして活果を乾式一増加荷重により実験し、これの側定行いるを示し、各テストピーストで向一条件で行をでいる。グラフ中横軸を荷重ね、縦軸を懸係のかった。しているのとして示し、テストピースとして対質S18Cに(16ダ×100^L)を用いた。

このグラフにおいてAは軟量化硬化処理材を、 りは便質クロムメッキ処理材を、CはMo 溶射材 を、Dは本発明にかかる表面硬化処理方法として

-7-

イオン窒化処理後前記ガス供給手段3,6を止め、別の手段10から Ar ガスを導入し、ガスに10⁻³ Torr 程度の努囲気中で金属材料8に近年を印加し、所足の時間スパッタリング溶着を行うのこのさい前記プロテクター9はこれを支持する。のな杆11で金属材料8から離し、プラズマ空間の妨げにならない位置に旋回等して調節される。又

映窓化便化処理を施し、Moをプレーテインク法でコーテインクしたものを用いた。グラフで明らかな如く、Aは摩擦係数が大きく、荷重75㎏近傍で焼付を起し、BはAに比し摩擦係数は小さいが荷重38㎏近傍でコーテイング層の剝ばか発生した。

しかるに本発明にかかるテストピースは D で示す如く摩擦係数が小さく、且つ荷重 9 0 kp 近傍でも焼付が発生せず、前記を実証した。

第3 図及び第4 図は本発明にかかる表面処理方法を実施するための具体的装置の一例を示しており、何れもイオン望化処理により表面硬化処理を行い、更に前記の如く被膜形成を行う方法を示している。

第3図はイオン窒化処理と被膜形成処理を同一 炉内で同時且つ連続的に行う実施例を示し、以下 にその磁略を説明する。炉1内に被処理物Wを装 入し、真空ポンプ2で内部を真空にし、ガス供給 手段3で112 ガス等を導入し、この雰囲気内で金

- 8 -

被処理物Wを所定の温度に保持するために加熱体 5の通電も適宜調節される。

以上はイオン選化処理で表面硬化処理を施したが前記の如く話種の表面硬化処理法を用い得るととは勿論で、又この処理後の気相表面処理手段で前記した如くスペッタリング法。イオンプレーティング法、TiC 被殺法等適宜に選択できる。

第4図は前記した装置を分割し、連続炉とした 実施例で、被処理物Wは予熱室20で窒化処理温 度近傍まで予熱され、シャッター21を開いてイ オン窒化処理室22内へ導き、真空ポンプ23で 抜気し、H2,N2ガス等を供給手段24で導入し、 支持体25上の被処理物Wに前記の如くイオン窒 化処理を施こす。

次いでシャッター26で気密に区画されたスパッタリンク室27内にこのシャッター26を開いて発化処理物と扱入し、シャックー26を閉じて室27内を真空ポンプ28で抜気し、Ar ガス等を供給手段29で導入し、金腐材料3リに電圧を印加し、所定の時間スパッタリ

ング溶着を行う。以後シャッター31を開いて冷却室32へ両処理後の被処理物 W を送り出す。これによれば各処理を工程順に違続して行うことができ、最産化上好都合である。

以上の実施例も前記第3図の実施例と同様である。

以上の説明で明らから如く本発明によれば、表面便化処理可能な金属材料を、先ず表面硬化処理し、次のでスタリング法,イオンブンでで、Mo、TiC被費法等の気相表面処理法でCr、Mo、W等の高融点で質金属被膜の形成を行うにしため、機械的性質に優れ、且つ耐熔耗性、耐熱性に優れ、高硬度の金属製品が得られた。

- 11 -

明的断面図、第2図は本発明と従来手段とのテストピース相互の実験結果を説明するためのグラフ、第3図及び第1図は本発明を実施するための装置の一例を示す説明的側断面図である。

尚図面中 a は基材、b は硬化層、c は被膜である。

特 許 出 顧 人 本田技研工業株式会社

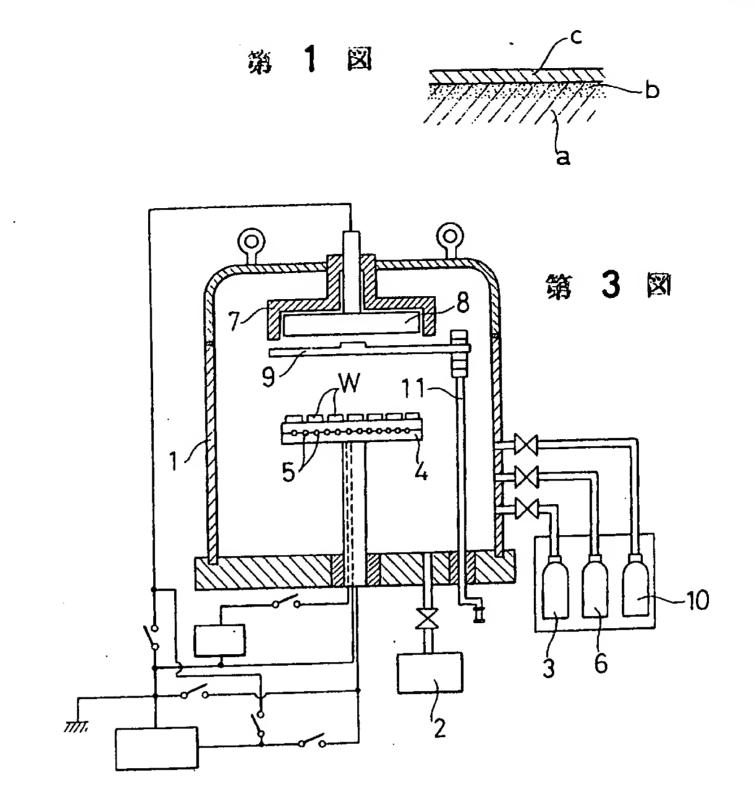
 代理人弁理士
 下
 田
 谷
 中

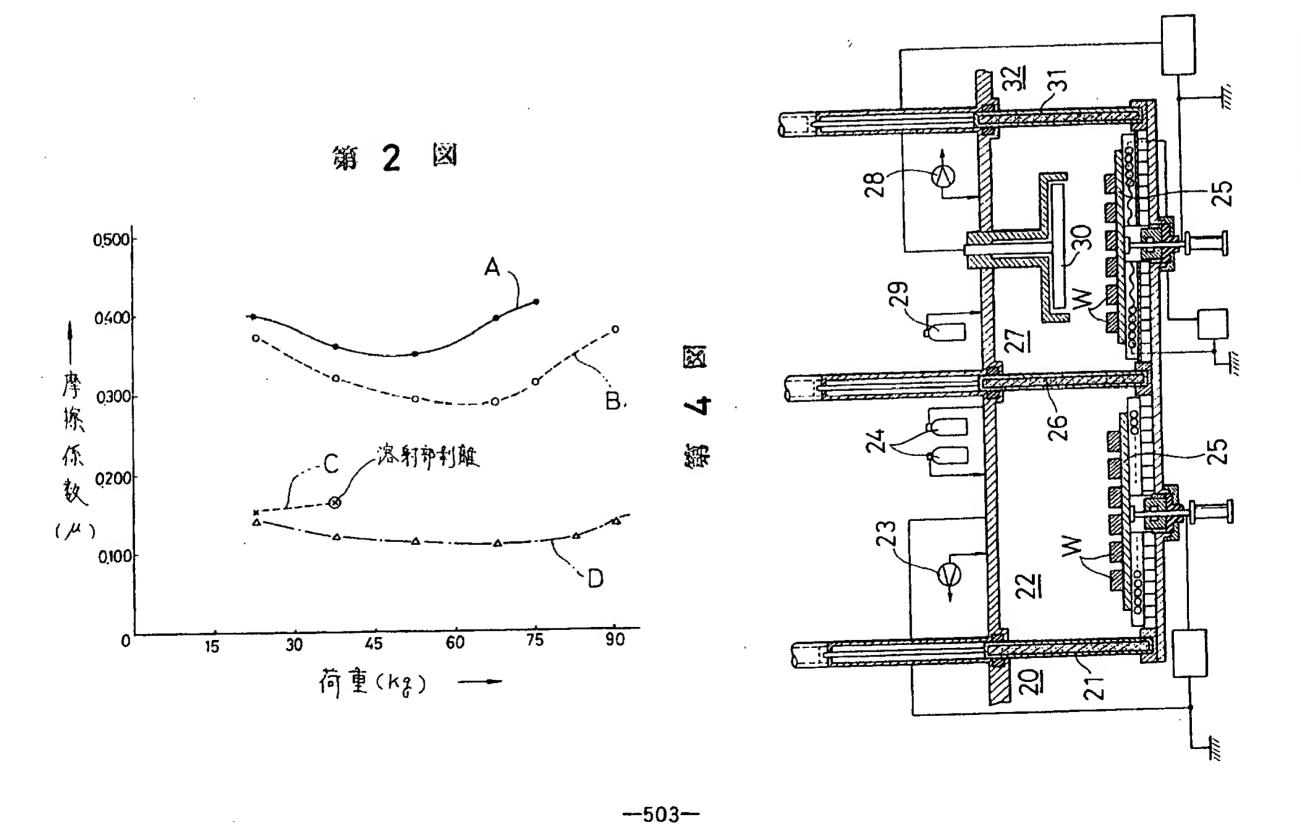
 同
 絹
 谷
 信
 堆

基材と被膜間の密着度を向上させ、又破膜の機械的性質、即ち別離強度等を向上させ、関にと処理により耐寒性に関われた高便度ので変勢に対している。 が得られ、従っていかって、ができる。 金銭組させることができる。

第1凶は本発明にかかる被処理物の一部拡大説

- 12 -





12/13/2002, EAST Version: 1.03.0002

SURFACE PROCESSING METHOD OF METALS

Shigemi Hatakeyama and Shigeku Setani

UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. JANUARY 2003
TRANSLATED BY THE RALPH MCELROY TRANSLATION COMPANY

JAPANESE PATENT OFFICE PATENT JOURNAL

KOKAI PATENT APPLICATION NO. SHO 52[1977]-111891

Int. Cl.²:

C 23 C 13/00
C 23 C 11/00
C 23 C 15/00

Japanese Classification: 13(7)D6
12A25
12A26
12A27

12A3 20(3)E0

Sequence Nos. for Office Use: 7128-42 7619-42

6816-41

Filing No.: Sho 51[1976]-28633

Filing Date: March 18, 1976

Publication Date: September 19, 1977

No. of Inventions: 1 (Total of 5 pages)

Examination Request: Not filed

SURFACE PROCESSING METHOD OF METALS

[Kinzoku no hyomen shori hoho]

Inventors:

Shigemi Hatakeyama and Shigeku Setani

Applicant: Honda Giken Kogyo K.K.

[There are no amendments to this patent.]

Claim

A surface processing method of metals characterized by forming a hardened layer through a surface hardening process in a surface layer area of a base material consisting of a metallic material that can be processed for surface hardening, and successively forming a metallic coat on the surface of this hardened layer of the base material with a high fusion point hard metal, such as Mo, W, Cr, Ni, TiC, and TiN, for example, by a gas phase surface processing method, such as an ion plating method, sputtering method, or a TiC coating method, for example.

Detailed explanation of the invention

This invention concerns a surface processing method for improving the hardness and the abrasion resistance of a metal through a gas phase surface processing after a surface hardening processing of the metal. It particularly concerns a surface processing method, in which a relatively inexpensive low-grade material that can be processed for surface hardening, such as chromium molybdenum steel and carbon steel for mechanical structures (SCM22, S45C), for example, is used. This is first processed for surface hardening by a carbonitriding method or an ion nitriding method, for example, the surface of this base material then receives a gas phase surface processing by an ion plating method, sputtering method, or a TiC coating method, for example, and a hard metallic product with an improved abrasion resistance is obtained.

With high-speed mechanical sliding parts, such as valve locker arms and dif-pinion shafts, for example, in addition to the requirement of a property such as strength for bending and twisting, satisfaction of severe conditions properties, such as heat resistance or abrasion resistance, for example, is also required.

Accordingly, the following surface processing methods have been conventionally used to conform the aforementioned mechanical parts, for example, to the aforementioned conditions.

More precisely, processing for surface hardening by a method which flame coats a high fusion point metal, such as Mo or W, for example, by plasma flame coating, for example, on the surface of the base material, processing by a method which coats the surface of the base material by hard chrome plating by an electric plating method, and surface hardening processing of the base material by a carbonitriding method or a nitriding hardening method, such as gas soft nitriding, salt bath nitriding, or ion nitriding, for example, have been used.

Regarding such conventional measures, the post-processing is complicated and difficult in the aforementioned flame coating method. Issues occur in the life expectancy of tools and other items. There also is a possibility for the occurrence of separation, and there are issues with separation strength as well. In the aforementioned plating processing method, separation also occurs easily in the boundary area between the base material and the plating layer, the process also requires a relatively long processing time and is not time economically desirable, and an

issue of pollution also exists. General condition performance is sufficient in the surface hardening processing method, however, when a mechanical part that must perform in the severe conditions described above is prepared, it is very difficult to obtain sufficient durability.

While considering the aforementioned present circumstances and issues in the surface processing methods of mechanical parts, for example, that require the severe condition properties such as mechanical strength, heat resistance, or abrasion resistance, for example, described above, the inventors of this invention performed diligent research on the obtainment of metallic products with excellent mechanical strength for bending and twisting, for example, as well as with excellent heat resistance and abrasion resistance, and this invention was completed.

The inventors of this invention have paid attention to gas phase surface processing methods, such as an ion plating method, sputtering method, or a TiC method, for example, have studied several types of said methods for obtaining surface processing through them, have proposed that application to products with a high Hertz stress is difficult when directly coating a high fusion point metal, such as Cr or Mo, for example, on the surface of a low-grade material because the strength of the base material is weak if the hard coating film is not formed thickly, and that they are not suitable for products that become fragile when bending, twisting, and impact, for example, are applied when the coating film is thick, and have gained the knowledge that the level of adhesion between the base material and the coating film increases by giving a surface hardening processing prior to this coating and then giving the aforementioned gas phase surface processing afterwards, so the mechanical performance improves, the heat resistance, abrasion resistance, and the impact resistance, for example, also improve, and a metallic material that can sufficiently withstand severe conditions can be obtained, and through this the invention has been completed.

Accordingly, the objective of this invention is to offer a surface processing method as a surface processing method for mechanical parts, for example, that undergo severe conditions like in mechanical sliding parts, for example, which allows one to obtain a metallic product with excellent mechanical strength for bending and twisting, for example, as well as with an excellent heat resistance, abrasion resistance, and impact resistance and said product sufficiently satisfies the aforementioned conditions.

Another objective of this invention is to offer a surface processing method which uses a base material that can be processed for surface hardening as the base material, such as inexpensive low-grade materials, such as SCM22 and S45C, for example. Accordingly, metallic products that sufficiently satisfy the aforementioned conditions can be obtained using inexpensive base materials, and the aforementioned can be economically mass-produced.

Application examples of this invention will be described in detail along with the figures attached below.

Metallic materials that can be processed for surface hardening are used in the surface processing method in this invention. These materials are acceptable if surface hardening processing is possible. Accordingly, relatively inexpensive low-grade materials, like common surface hardening processing materials, such as SCM22 and S45C, for example, are used. Base material (a) consisting of this material is processed for surface hardening, and hardened layer (b) is formed in the surface layer part. As this surface hardening processing measure, a carbonitriding method, ion nitriding method, salt bath nitriding method, and gas softening nitriding method, for example, are used, and the hardness of the surface layer part of the base material is strengthened, and the base material is strengthened.

Then, a high fusion point hard metal, such as Mo, W, Cr, Ni, TiC, or TiN, for example, is gas phase surface processed onto the base material, to which the surface hardening processing has been given, by an ion plating method, sputtering method, or TiC coating method, for example, an abrasion resisting metallic coating layer (c) is formed on the surface of the hardened layer (b), and a metallic material that withstands the aforementioned severe conditions, such as one with heat resistance and an abrasion resistance, for example, is obtained at the end.

At the formation of this metallic coating layer (c), the surface hardening processing is first given because when a low-grade material is directly coated with a high fusion point hard metal, such as Cr, Mo, or W, for example, the application to products with a high Hertz stress is difficult unless the hard coating layer is formed relatively thickly because the strength of the base material is weak, and the product becomes fragile when the coating increases and is not suitable for products, to which bending, twisting, and impact, for example, are applied. Accordingly, when coating a high fusion point hard metal, such as Cr, Mo, or W, for example, it is necessary to increase the hardness of the base metal beforehand and to then form a hard coating layer on top of it.

In the above, when the hardness of the base metal material (a) is improved through surface hardening processing, such as ion nitriding or carbonitriding, for example, and a high fusion point hard metal, such as Cr, Mo, or W, for example, is coated by a gas phase surface processing method, such as an ion plating method, for example, while maintaining a proper temperature by heating, a very small quantity of C atoms and N atoms on the surface of the base metal penetrate into the coating part on the surface through a heat diffusion reaction, close adhesion between the base material and the coating, such as Cr, Mo, or W, for example, increases, and the mechanical performance of the coating layer improves, and a metallic material that sufficiently withstands severe conditions, such as one with heat resistance, abrasion resistance, and impact resistance, for example, is obtained. With the series of these processing methods, the hardness of the base material in the surface layer part of the base material surface is increased through the surface hardening processing, such as carbonitriding or nitriding, for

example, therefore, the formation of the coating may be thin. A surface hardening processing is given and the aforementioned coating is also formed on the surface. Therefore, the surface hardened layer may also be formed thinly when compared to a type with this alone. As a result, a hard metallic material with excellent heat resistance, abrasion resistance, and impact resistance can be obtained without sacrifice of mechanical properties like tenacity, bending, and twisting, for example, that are possessed by the base material.

The above will be explained in a graph in Figure 2. The graph uses a dif-pinion shaft as the test piece. This is tested using a dry method-increase load, and the results of the measurement are indicated. Each of test pieces A-D has the same conditions and lines A-D in the graph indicate the test pieces. In the graph, the horizontal axis indicates the load in kg, and the vertical axis indicates the coefficient of friction μ . Material S48C (16 ϕ x 100^L) is used as the test piece.

This graph uses a soft nitriding hardening processed material as A, a hard chromium plating processed material as B, a Mo flame-coated material as C, and one that is processed by a soft nitriding hardening as the surface hardening processing method in this invention with Mo coated by a plating method as D. As clearly shown in the graph, A has a large coefficient of friction, and burning occurs when the load is near 75 kg. B has a smaller coefficient of friction than A, but burning occurs when the load is near 90 kg, and C has a small coefficient of friction but the coating layer separates when the load is near 38 kg.

However, the test piece in this invention has a small coefficient of friction as indicated by D, burning does not occur even when the load is near 90 kg, and the aforementioned is proven.

Figures 3 and 4 show examples of concrete systems for the implementation of the surface processing method in this invention. Both indicate methods for giving surface hardening processing through ion nitriding processing and further forming a coating as described above.

Figure 3 shows an application example, in which ion nitriding processing and coat forming processing are simultaneously and continuously obtained within the same furnace, and its details will be explained below. Material to be processed (W) is placed within a furnace (1), the inside is evacuated by a vacuum pump (2), H₂ gas, for example, is introduced by a gas supplying measure (3), for example, and a dc voltage is applied between the metallic material (8) and the support (4) of the material to be processed (W) in this atmosphere, and said material to be processed (W) is heated to near the nitriding processing temperature through ion bombardment. Electricity may also be applied to a heating member (5), which is embedded in the support (4) of the material to be processed (W), and it may be heated in combination with ion bombardment. Next, gases, such as H₂ and N₂, for example, are introduced in at proper proportions by gas supplying measures (3) and (6), and ion nitriding processing is obtained under a gas pressure of 1-10 torr in a specific period of time. During this, the coating metallic material (8), which is supported by an insulating and shielding member (7) at the upper part within the

furnace (1), is covered and protected by a conductive protector (9). This is used as an anode during nitriding processing, and the contamination of the material to be processed (W) and the support (4) during sputtering is prevented.

The aforementioned gas supplying measures (3) and (6) are stopped after the ion nitriding processing, Ar gas is introduced by another measure (10), a voltage is applied to the metallic material (8) in an atmosphere of gas pressure of about 10^{-3} torr, and sputtering welding is performed for a specific period of time. During this, the aforementioned protector (9) is separated from the metallic material (8) by an adjusting bar (11), which supports said protector, and said protector rotates, for example, and is adjusted to a position that does not interfere with the plasma space. The application of electricity to the heating member (5) is also properly adjusted for maintaining the material to be processed (W) at a specific temperature.

In the above, the surface hardening is processed through ion nitriding processing, however, the various types of surface hardening processing methods described above can certainly be used, and a sputtering method, ion plating method, or TiC coating method, for example, as described above can also be properly selected as the gas phase surface processing method after this processing.

Figure 4 shows an application example, in which the aforementioned system is separated as a continuous furnace. Material to be processed (W) is pre-heated in a pre-heating chamber (20) to near the nitriding processing temperature and guided into an ion nitriding processing chamber (22) as a shutter (21) opens, which is deaerated by a vacuum pump (23), H₂ and N₂ gases, for example, are introduced by a supplying measure (24), and the material to be processed (W) over the support (25) receives ion nitriding processing as described above.

Then, the shutter (26) opens, and the material to be processed (W), for which nitriding processing has been completed, is conveyed into a sputtering chamber (27), which is air-tightly sectioned by this shutter (26). The shutter (26) then closes, the inside of the chamber (27) is evacuated using the vacuum pump (28), Ar gas, for example, is introduced by the supplying measure (29), and a voltage is applied to the metallic material (30), and sputtering welding is performed for a specific period of time. The shutter (31) is afterwards opened, and the material to be processed (W) after both processes is sent to a cooling chamber (32). Through this, each processing can be continuously obtained in the processing order, which is convenient for mass production.

The application example above is the same as the aforementioned application example in Figure 3.

In this invention as clearly explained in the explanation above, a metallic material that can be processed for surface hardening is first processed for surface hardening, and a high fusion point hard metallic coat, such as Cr, Mo, or W, for example, is then formed by a gas phase

surface processing method, such as a sputtering method, ion plating method, or a TiC coating method, for example. Therefore, a hard metallic product with excellent mechanical performance as well as with excellent abrasion resistance and heat resistance is obtained.

More precisely, through this invention, a low-grade material, such as SCM22, for example, that can be processed for surface hardening, such as a common steel, for example, is processed for surface hardening by a measure like ion nitriding and carbonitriding, for example, and a high fusion point metallic coat, such as Cr, Mo, or W, for example, is formed by the aforementioned on the surface of this hardening processed layer. Therefore, C atoms and N atoms on the surface of the base material are partially diffused thermally, for example, through maintenance of temperature after hardening processing, and penetrate, for example, into the coat material. Through this, the adhesion between the base material and the coating improves, the mechanical performance of the coating, that is, the separation strength, for example, improves, and a processed hard material with excellent heat resistance and abrasion resistance is obtained. Accordingly, sufficient durability can be displayed in metallic products, such as valve locker arms and dif-pinion shafts, for example, that are used in mechanically sliding parts even under severe conditions.

Through this invention, in addition to the aforementioned, low-grade materials, for example, are used, and the aforementioned coating formation processing is used in combination after the surface hardening processing. Therefore, the respective processing layer and coating may be formed thinly. As a result, a hard metallic product that has strong tenacity against bending or twisting, for example, can be obtained without hurting the characteristics of the material itself. The practicability of metallic products can be improved, and inexpensive materials can also be used. The surface hardening processing and the coat formation processing can be minimized unlike when they are respectively obtained independently. Accordingly, various characteristics are displayed, such as the obtainment of the aforementioned very excellent metallic products at low cost as well as with mass production, and the practicability is great.

Brief description of the figures

Figure 1 is an explanatory cross-sectional illustration of a partially enlarged material to be processed in this invention. Figure 2 is a graph, which explains the experimental results of test pieces of this invention and of conventional measures. Figures 3 and 4 are explanatory side cross-sectional illustrations showing examples of systems in the implementation of this invention.

In the figures, (a) is a base material, (b) is a hardened layer, and (c) is a coating.

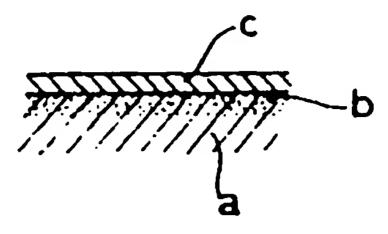


Figure 1

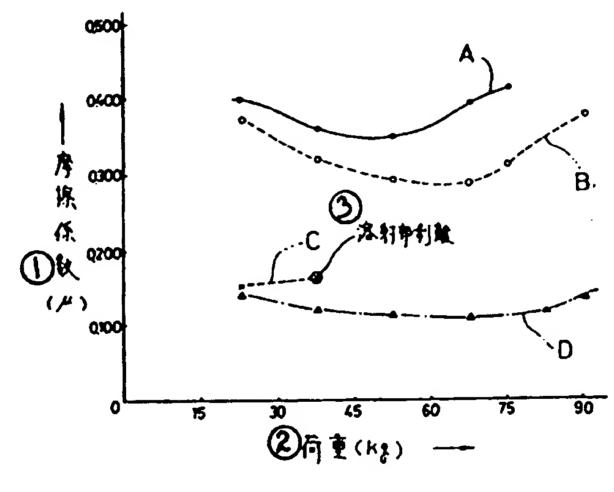


Figure 2

Coefficient of friction (μ) Key:

- Load (kg) Separation in the flame coating part

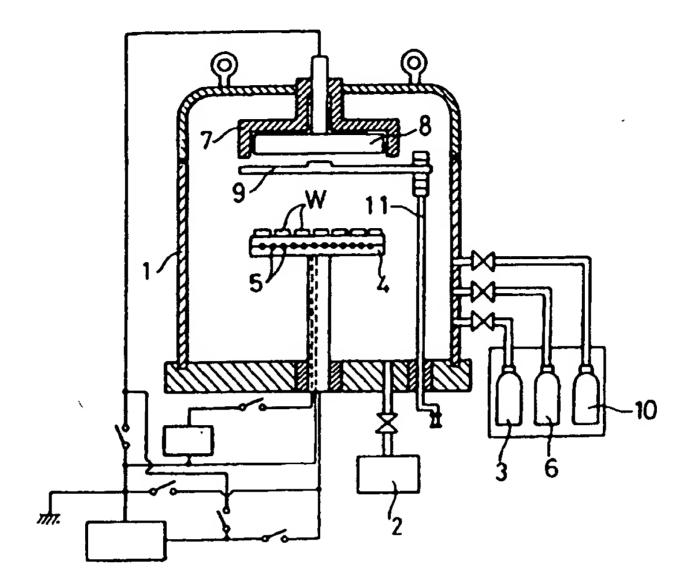


Figure 3

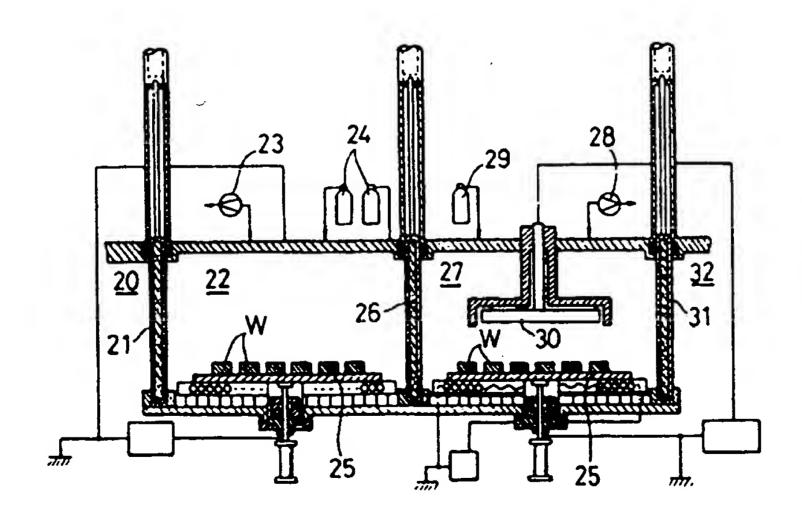


Figure 4